

Electronic Patent Application Fee Transmittal

Application Number:	10694986
Filing Date:	29-Oct-2003
Title of Invention:	Method for removing resist pattern and method for manufacturing semiconductor device
First Named Inventor:	Masaharu Nagai
Filer:	John F. Hayden/Andrea Turner
Attorney Docket Number:	12732-171001

Filed as Large Entity

Utility Filing Fees				
Description	Fee Code	Quantity	Amount	Sub-Total in USD(\$)
Basic Filing:				
Pages:				
Claims:				
Claims in excess of 20	1202	1	50	50
Miscellaneous-Filing:				
Petition:				
Patent-Appeals-and-Interference:				
Post-Allowance-and-Post-Issuance:				
Extension-of-Time:				

Description	Fee Code	Quantity	Amount	Sub-Total in USD(\$)
Miscellaneous:				
Request for continued examination	1801	1	790	790
Total in USD (\$)				840